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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/750,845	01/05/2004	Sung-Chul Kang	YOM-0205	YOM-0205 3873	
23413	7590 10/04/2006		EXAMINER		
CANTOR COLBURN, LLP			CHU, JOHN S Y		
55 GRIFFIN	ROAD SOUTH				
BLOOMFIELD, CT 06002			ART UNIT	PAPER NUMBER	
	•		1752		

DATE MAILED: 10/04/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

C /

	Application No.	Applicant(s)
	10/750,845	KANG ET AL
Office Action Summary	Examiner	Art Unit
	John S. Chu	1752
The MAILING DATE of this communication app Period for Reply A SHORTENED STATUTORY PERIOD FOR REPL WHICHEVER IS LONGER, FROM THE MAILING D - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period - Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b). Status 1) Responsive to communication(s) filed on 27 S 2a) This action is FINAL. 2b) This 3) Since this application is in condition for allowa	Y IS SET TO EXPIRE 3 MONTH(ATE OF THIS COMMUNICATION 36(a). In no event, however, may a reply be time will apply and will expire SIX (6) MONTHS from a, cause the application to become ABANDONE g date of this communication, even if timely filed september 2006. Se action is non-final.	S) OR THIRTY (30) DAYS, I. ely filed the mailing date of this communication. D (35 U.S.C. § 133). , may reduce any
closed in accordance with the practice under E	Ex parte Quayle, 1935 C.D. 11, 45	3 O.G. 213.
Disposition of Claims 4) ☐ Claim(s) 11-14 and 16-20 is/are pending in the 4a) Of the above claim(s) is/are withdra 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 11-14 and 16-20 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or contents.	wn from consideration.	
Application Papers		
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) accomposed and applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Example 11. Priority under 35 U.S.C. § 119	epted or b) objected to by the E drawing(s) be held in abeyance. See tion is required if the drawing(s) is obj	e 37 CFR 1.85(a). ected to. See 37 CFR 1.121(d).
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Burea * See the attached detailed Office action for a list	ts have been received. Is have been received in Application In the price in the price ive In the price in the	on No ed in this National Stage
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:	ite

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DETAILED ACTION

This Office action is in response to the RCE filed September 27, 2006

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 11-14 and 16-20 are rejected under 35 U.S.C. 103(a) as being unpatentable over JEFFRIES, III et al (5,346,799) or EBERSOLE (5,324,620) in view of KODAMA et al (5,853,949) SHERIFF et al (6,117,610) and GRACIA et al (6,232,031 B1).

The claimed invention has been recited hereafter:

- 11. (Currently Amended) A method for applying a photoresist composition to a large-scale substrate by an MMN head coater, wherein the photoresist composition comprises:
- (a) 5 wi% to 30 wi% of a polymer resin represented by the following Chemical Formula 1;
 - (b) 2 wt% to 10 wt% of a diazide photoactive compound;
 - (c) 50 wt% to 90 wt% of an organic solvent; and
 - (d) 500 to 4000 ppm of a Si based surfactant:

Chemical Formula 1

wherein R is C_1 to C_4 alkyl, and n is an integer of 15 to 10,000, and wherein the Si-based surfactant is a polyoxyalkylene dimethylpolysiloxane copolymer compound,

wherein the composition and content of solvent and surfactant is controlled to prevent stains and improve coating characteristics in a photoresist film formed on the substrate from the photoresist composition, and

wherein stains include contral stains, lateral stains, or cloudy stains.

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and is included by reference wherein claim 6 is further drawn to the addition of a crosslinking agent is shown below:

16. (withdrawn) The method of Claim 11,

wherein the composition further comprises one or more nitrogen-containing crosslinking agents selected from the group consisting of a condensation product of urea and formaldehyde, a condensation product of melamine and formaldehyde, a methylol urea alkylether, and a methylol melamine alkylether.

Each of JEFFRIES, III et al, or EBERSOLE recite a photoresist composition comprising a S-based surfactant in a composition comprising a novolak resin and a quinonediazide compound. Said references fail to teach the use of a crosslinking agent in the photoresist composition as currently recited in claim 6.

KODAMA et al '949 discloses a positive photoresist composition comprising a novolak resin and a quinonediazide compound with the addition of a polyphenol compound, see <u>column 6, lines 32 – column 7, line 60</u> for the alkali-soluble resin and photosensitive compound. Applicants are directed to <u>column 11, lines 46-51</u> wherein KODAMA et al teaches the use of surfactants being Si-based. In fact the same surfactants as disclosed in JEFFRIES, III et al and EBERSOLE are disclosed here in KODAMA et al, see the surfactant trade name of FLORAD FC-430 in <u>column 11, line 46</u>.

The primary disclosure which the examiner relies on is found in column 12, lines 40-56 wherein KODAMA et al discloses the suitable use of crosslinking agents which serve to improve the dry etching resistance, improve sensitivity and heat resistance, yet not alter the positive working property of the photoresist composition. Specific crosslinking agents include

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melamine-formaldehyde and others like benzoguanamine and glycouril-formaldehyde. Thus the skilled artisan is motivated to use such components to improve the photoresist image that is formed.

Each of SHERIFF et al and GRACIA et al are cited of interest with respect to the use of polyether modified dimethylpolysiloxane copolymer surfactants. The <u>Examples 3-6</u> in SHERIFF et al disclose the following attached:

EXAMPLES 3-6

Four imaging compositions and plates of the present invention were prepared using the following components:

COMPONENT	Example 3 (grams)	Example 4 (grams)	Example 5 (grams)	Example 6 (grama)
Cresol-formaldehyde novolac resin	4.620	4.620	4.620	4.620
2,4-Bis(2-diazo-1,2-dihydro-1-oxo-5-naphthalenesulfonyloxy)	1.154	1.154	1.154	1.154
benzo-phenone Carbon black	0.108	0.217	0.434	0.868
1-Methoxy-2-propanol solvent	88.118	88.009	87.792	87.358
Acetone	5.881	5.881	5.881	5.881
CG-21-1005	0.108	0.108	0.108	0.108
BYK-307	0.011	0.011	0.011	0.011

CG 21-1005 is a dye available from Ciba-Geigy.

BYK-307 is a polyether-modified polydimethylsiloxane available from BYK-Chemie.

wherein BYK-307 is a surfactant as claimed in claim 11.

GRACIA et al likewise discloses the use of BYK 344 surfactant in Examples 1-4 in a composition with a quinone diazide compound and a novolak resin. Here the use of a polyoxyalkylene dimethylpolysiloxane copolymer surfactant is taught in a composition for photolithographic compositions comprising a diazide compound a phenol novolak resin and a

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solvent. BYK 333 and BYK 344 are attached with their product descriptions from the BYK-Chemie product list.

It would have been *prima facie* obvious to one of ordinary skill in the art of positive photoresist compositions to add a crosslinking agent, such as melamine-formaldehyde into the photoresist composition of JEFFRIES, III et al or EBERSOLE as an agent to improve dry etching resistance, and heat resistance and reasonably expect same or similar results as disclosed in JEFFRIES, III et al or EBERSOLE for high thermal resistance and low scumming upon development.

It also would have been *prima facie* obvious to one of ordinary skill in the art of photolithographic compositions and coating methods to add the known surfactants as disclosed in SHERIFF et al and GRACIA et al into the compositions of JEFFRIES, III et al, EBERSOLE and reasonably expect same or similar results with respect to having compositions with high thermal resistance.

The argument by applicant have been carefully considered, however it is believed that a prima facie case of obviousness is present wherein each of the components are disclosed to be known and one of ordinary skill in the art would be directed to use the crosslinking agent and the surfactants as disclosed above. The examiner notes that the arguments for the coating method on a large-scale is known and disclosed, the controlling steps to prevent stains and to improve coating properties are inherently present in the methods of the prior art. Applicants have not disclosed how to "prevent stains" or improve coating characteristics in the method, such that when using the components as disclosed in

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the references, because the properties and the compounds are inseparable, if the

components are there, the properties are also present.

Any inquiry concerning this communication or earlier communications from the 4.

examiner should be directed to Examiner Chu whose telephone number is (571) 272-1329. The

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examiner can normally be reached on Monday - Friday from 9:30 am to 6:00 pm.

If attempts to reach the Examiner by telephone are unsuccessful, the Examiner's

supervisor, Cynthia Kelly, can be reached on (571) 272-1526

The fax phone number for the USPTO is (571) 273-8300.

Information regarding the status of an application may be obtained from the Patent

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system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR

system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Primary Examiner, Group 1700

J.Chu

October 2, 2006